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## PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88662

Takenori OSADA, et al.

Appln. No.: 10/540,513

Group Art Unit: 2826

Confirmation No.: 6641

Examiner: Eduardo A. Rodela

Filed: June 23, 2005

For:

COMPOUND SEMICONDUTOR EPITAXIAL SUBSTRATE AND METHOD FOR

MANUFACTURING THE SAME

## PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of three months, extending the time for responding to the Office Action of March 19, 2007, to September 19, 2007.

The statutory fee of \$1020.00 is being charged to Deposit Account No. 19-4880. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy is enclosed.

Respectfully submitted,

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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: September 13, 2007

olln T. Callahan

Régistration No. 32.,607

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